Application/Control No. Applicant(s)/Patent Under Reexamination 10/695,396 KIM ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 David Y. Chung 2871 **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY US-6,704,066 03-2004 Α Tsumura et al. 349/42 * US-2002/0044246 04-2002 В Moon et al. 349/141 US-С US-D US-Ε US-F US-G Н US-US-١ US-J Κ US-US-L US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Country Country Code-Number-Kind Code Name Classification MM-YYYY Ν 0 Р Q R s Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U W

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